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MAY 25 2006

Patent

Customer No. 31561  
Docket No. 12595-US-PA  
Application No.: 10/711,622**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Applicant : Shih et al.  
Application No. : 10/711,622  
Filed : September 29, 2004  
For : POLISHING PAD AND FABRICATING METHOD  
THEREOF  
Examiner : ACKUN, JACOB K  
Art Unit : 3723

**INFORMATION DISCLOSURE STATEMENT**

+1-571-273-8300

(Via fax: 2+1+37 pages)

United States Patent and Trademark Office  
Customer Service Window, Mail Stop **Amendment**  
Randolph Building  
401 Dulany Street  
Alexandria, VA 22314

Enclosed is a PTO Form 1449 listing 3 reference(s), copy of which are attached. Applicants submit the reference(s) in compliance with their duty of disclosure pursuant to 37 CFR § 1.56 and 1.97. The Examiner is requested to make the citation(s) of official record.

The IDS is being submitted after the mailing date of a Final Office Action/ Notice of Allowance. Attached herewith please find a copy of Applicants' statement under 37 CFR § 1.97 (e).

Please charge the payment in the amount of US\$180.00 to account No. 50-2620 (Order No.: 12595-US-PA) to cover the fee set forth in 37 CFR 1.17(p).

The submission of the reference(s) should not be interpreted as admitting them as prior art.

Respectfully Submitted,  
JIANQI CHYUN Intellectual Property Office

Date: May 25, 2006By: Belinda Lee  
Belinda Lee  
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FORM PTO-1449 U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE INFORMATION DISCLOSURE STATEMENT BY APPLICATION	ATTY. DOCKET NO.: 12593-US-PA	APPLICATION NO.: 10/711,622
	APPLICANT: Shih et al.	
	FILING DATE: Sep. 29, 2004	GROUP 3723

**U.S. PATENT DOCUMENTS**

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE (IF APPROPRIATE)
	5,921,855	Jul. 13, 1999	Osterheld et al.	451	527	May 15, 1997

**FOREIGN PATENT DOCUMENTS**

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	FILING DATE (IF APPROPRIATE)
	JP 2003-117805	Apr. 23, 2003	JAPAN			Oct. 16, 2001
	KR 1998-087060	Dec. 5, 1998	KOREA			May 15, 1998

EXAMINER INITIAL	OTHER DOCUMENTS (INCLUDING AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.)

EXAMINER	DATE CONSIDERED
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EXAMINER: INITIAL IF CITATION CONSIDERED, WHETHER OR NOT CITATION IS IN CONFORMANCE WITH MPEP 609; DRAW LINE THROUGH CITATION IF NOT IN CONFORMANCE AND NOT CONSIDERED. INCLUDE COPY OF THIS FORM WITH NEXT COMMUNICATION TO APPLICANT.

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**STATEMENT UNDER C.F.R. 1.97(c)**

I/We hereby state that each item of information contained in the information disclosure statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the information disclosure statement.

Date

May 25, 2006

By

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